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				U.S. PATENT DOCUM	MENTS	
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STA	TEMENT	RY AF	PPLICANT	First Named Inventor	Seunava Koh etal		
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		OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS	
Examinar Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the tem (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	r
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